OPTICAL AND ELECTROCHEMICAL STUDY OF THE SULPHIDE/SILVER SYSTEM

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(Received 8 February 1993; in revised form 9 June 1993)

Abstract—The behaviour of suphide species at a silver/electrolyte interface along with the electrodeposition of thin Ag_2S films have been studied by a combination of electrochemical and *in situ* optical methods. The potential region between -1.08 and -0.470 V (*nhe*), pre-peak zone, is mainly characterized by a reversible process, at -0.870 V, overlapping and catalysing the *her*, ascribed to the formation of an $Ag-(SH^-)_{ads}$ bond. Phase Ag_2S deposits were found to fit a linear relationship between reflectance, in the blue region, and charge. The oxidation of surface Ag_2S (postwave) is readily observed by differential reflectance at potentials positive of the onset of bulk Ag_2S formation. The rough silver surface brought about by the reduction of Ag_2S allows a strong coupling between photons and surface plasmons.

Key words: thin films, sulphide electrodeposition, silver tarnishing, plasmons, electroreflectance.

1. INTRODUCTION

Silver sulphide films have been a subject of increasing interest in the last few years because of their elecproperties[1-9]. trical and optical The electroformation of silver sulphide films on silver metal is of interest for its application to ion selective electrodes[10] and, from the viewpoint of corrosion studies, in relation to the tarnishing phenomena of silver. The electrochemical recovery of silver from silver sulphide materials is also of industrial relevance. In addition, silver sulphide systems have been investigated with a view to developing superionic conductors[11] and photosensitive materials for recording media[12].

In this communication we present data, obtained through *in situ* optical (uv-visible) and electrochemical techniques, for relatively thin films of silver sulphide, not thicker than *ca.* 100 Å, grown on polycrystalline silver electrodes with the aim of providing complementary information on the properties of the film species.

2. EXPERIMENTAL

Optical measurements were obtained with *p*polarized light at an incident angle of 59° using either a reflectance spectrometer specially designed for electrochemical systems with the aid of potential modulation[13], or a computerized optical multichannel analyser (OMA) fitted with a cooled Si diode array. This rapid-scan spectrometer was employed to obtain two types of integral spectra, namely during slow linear potential sweeps, *ca.* 2 mV s^{-1} , every spectrum resulting from the coaddition in computer memory of 100 exposures, each averaged 0.03 s on the diode array chip and after a potential step, monitoring the ensuing transient by means of successive spectra comprising of 50 exposures of 0.03 s each. Diffraction orders higher than one were sorted out by appropriate filters. Electrochemical experiments were carried out in a conventional way.

The working electrode was a Kel-F-encased silver disc (Specpure, Johnson Matthey), polished to a mirror finish with alumina and cleaned in an ultrasonic bath before being introduced into the deoxygenated supporting electrolyte. Solutions were prepared with redistilled Millipore water and pa. grade Na₂S.9 H₂O (Merck). The base electrolyte was a borate buffer (Merck pa.) of pH 9.2. Potentials were measured against a mercurous oxide reference electrode and are quoted on the normal hydrogen electrode scale.

3. RESULTS AND DISCUSSION

3.1. Electrochemical characterization

Conventional voltammetric runs were carried out to define the potential zones where the different processes develop and to determine the relationships that characterize their behaviour. The observed current response (Fig. 1) coincides on the whole with that reported by Hepel et al.[7] with the expected changes arising from the difference between the solution pH of the two studies. However, in addition to the optical information, further details are presented in the electrochemical data of this work, ie a postwave in the bulk deposition of silver sulphide, and the presence of peak A_1 , emphasized as the most relevant in the pre-peak zone (vide infra). The voltammogram in Fig. 1 shows two main potential regions, the pre-peak region between -1.08 and ca. -0.470 V, partially overlapping the hydrogen evolution reaction (her), and the zone where the electrodeposition and reduction of phase silver sulphide take place. The pre-peak region is dominated by the

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process that takes place at -0.870 V (described as A_1 below^{*}) that overlaps and catalyses at *her*, leading to the presence of a dip, C^* , on the positivegoing scan, followed by a small and sharp peak A_2 at -0.570 V. The negative wave C^* , is also observed, with the same sign, on the back scan. This peculiar behaviour of C^* could be explained by assuming the negative current (wave) arises from the *her* catalysed by the deposition of sulphide species A_1 at intermediate coverage[3]. The accumulated charge, up to -0.470 V, corresponding to both peaks A_1 and A_2 , was estimated for 2×10^{-4} M sulphide, in steady-state conditions, by means of chronocoulometry fol-



Fig. 1. Voltammogram run at 50 mV s^{-1} (single scan), covering the pre-peak and bulk silver sulphide potential regions; 2.5×10^{-4} M sulphide in sodium tetraborate solution, pH 9.2.

lowing the procedure detailed in [14] and found to be $ca. 200 \pm 20 \,\mu\text{C}\,\text{cm}^{-2}$.

At potentials positive of ca. -0.470 V, the electroformation of the phase silver sulphide can be observed, A_3 , under diffusion control, followed by a hump, A_4 , superimposed on the falling current profile of peak A_3 . The equilibrium potential of the sulphide/silver sulphide system was calculated by using the relationship reported in [4] and found to be -0.436 V for the concentration employed in this work. An effective diffusion coefficient for SH⁻ was calculated from a plot of charge vs. square root of time, the data being obtained from a potential step from -0.8 to -0.1 V. The value was found to be $1.19 \times 10^{-5} \text{ cm}^2 \text{ s}^{-1}$. Current peak A_4 was found to prevail upon A_3 at high sweep rates since the former grows as v instead of $v^{1/2}$. The wave A_4 is assigned to the oxidation of surface silver sulphide, its potential being more positive than A_3 on account of the higher stability of the surface species. On reversing the potential scan the postwave pair, C_4 , can be obtained, followed by the electroreduction of silver sulphide, peak C_3 , the profile being typical of a phase formation; that is, recrystallization of silver ions to give silver metal with the attending dissolution of sulphide ions. Under special experimental conditions, namely low sweep rates, 20 mV s^{-1} , peak C_3 was found to split into two components. The complementary peaks C_2 and C_1 are more pronounced than on the forward scan, particularly C_1 , which is also wider, probably due to the further reduction of species formed during the precedent scan. C_2 appears somewhat better resolved than A_2 because of the increase in surface roughness brought about by the process of formation/reduction of phase silver sulphide.

3.2. Optical measurements

3.2.1. Integral measurements. The system was studied by measuring the optical response to rather large potential perturbations, typically a few hundred millivolts.

Integral measurements, as a function of the wavelength, in the pre-peak region (Fig. 2a), exhibit a somewhat similar shape to that of phase silver sulphide films (Fig. 3). The absorption maximum corresponding to surface silver sulphide was found to be at 333 nm for thin films. However, 380 nm was selected for measurements in the blue region since it gave a more favourable signal/noise ratio due to the higher power of the quartz-halogen source at lower frequencies. Potentiostatic pulses were applied between -0.8 and -0.1 V, the optical response, (R $(-R_0)/R_0$, as taken at 380 nm (Fig. 4), exhibits a linear relationship when plotted against $t^{1/2}$ indicating the change of reflectivity of silver, at the chosen wavelength, is proportional to the amount of silver sulphide laid down.

Figure 3 shows spectra taken at 3.0-s intervals after a potential step between -0.65 and -0.15 V has been applied. In addition to the AgS₂ band at 339 nm, an intense plasmon contribution is observed at *ca.* 420 nm that tails slowly into the red region. However, silver sulphide itself is known to absorb radiation throughout the visible region as its band gap is reported to be 0.9 eV[15]. Nevertheless, higher

^{*} Process no. 1 is indicated as C^* because it shows on the cv as a negative current irrespective of the sweep slope, it arises however from the underlying surface reactions A_1/A_2 .



Fig. 2. Normalized integral reflectance measurements, $\Delta R/R$, as obtained by the difference between spectra at two given potentials. Spectra taken during scanning cyclically at 2 mV s^{-1} from -1.15 to -0.15 V. The individual reflectance spectra (R curves), at each potential, were 100 times averaged in memory, exposure time: 0.03 s, that is, each spectrum took 3 s, potentials quoted are starting values: p-polarized light, $\phi = 59^{\circ}$; 2.5×10^{-4} M sulphide; pre-peak region; spectra smoothed out by the Savitzky-Golay algorithm: (a) $\Delta R/R = (R_{-0.73V} - R_{-1.10V})/R_{-1.10V}$, forward scan; and (b) $\Delta R/R = (R_{-0.77V} - R_{-1.10V})/R_{-1.10V}$, back scan (the small break at 493 nm is an artifact).

energies for the band gap have been described for thin films[16].

On the other hand, the spectrum in the pre-peak region when observed on the back scan, after the reduction of phase silver sulphide, and compared with the spectrum taken on the forward scan for the same potential region, illustrate the relative enhancement of the surface plasmon excitation (Fig. 2b). This effect should likely arise from the increase in surface roughness. The behaviour is, on the whole, similar to the process of silver roughening in the presence of chloride ions by repetitive formation and reduction of AgCl which leads to the well-known effect of surface enhanced Raman[17].

In order to gain a finer insight into the reaction processes, not easily drawn from the broad features



Fig. 3. Time dependence of the integral change of reflectance vs. wavelength, $\Delta R/R = (R_{-0.15V} - R_{-0.65V})/R_{-0.65V}$, resulting from the formation of bulk silver sulphide: *p*-polarized light, angle of incidence $\phi = 59^{\circ}$; potential stepped from -0.65 to -0.15V. Each spectrum, measured during the ensuing transient, was averaged 50 times in memory, exposure time: 0.03s, that is, each curve took 1.5s. In this figure, however, they are spaced out 3s as only half of the total number of spectra (20) are shown. The final charge after 30s was determined to be *ca*. 1500 μ C cm⁻².



Fig. 4. Time dependence of the integral change of reflectance, $\Delta R/R$, attending the formation of bulk silver sulphide: potential stepped from -0.8 to -0.1 V; p-polarized light, angle of incidence $\phi = 59^{\circ}$; 380 nm. Inset: $\Delta R/R$ vs. $t^{1/2}$ relationship.

of the integral spectrum, differential measurements as a function of potential were carried out at set wavelengths.

3.2.2. Differential measurements. Reflectance determinations were carried out at fixed wavelengths, namely 380 and 680 nm, by sweeping the potential linearly between -1.08 and +0.02 V at 3.6 mV s^{-1} with a superimposed 50 mV amplitude modulation at 11 Hz. The optical signal was demodulated by a lock-in amplifier and the rectified in-phase component plotted vs. potential as in Fig. 5. The curve taken at 380 nm shows (Fig. 5a) on the forward scan, a large and broad maximum at ca. -0.900 V in the region corresponding to the C* dip of the voltammogram attending the electroadsorption of sulphide species, in a relatively fast process when compared to the modulation frequency. The species giving rise to this peak was found to catalyse the hydrogen evolution reaction as has been reported by Parsons *et* al.[3]. Its presence has also been suggested by Horányi and Vértes [6]. The reaction involved in this process can be written, as has been proposed for gold electrodes [14, 18],

leading to interacting surface species with a significant ionic character and enough kinetic reversibility so as to follow the potential modulation. Process A_2 is detected as a small, sharp peak on the falling optical response of reaction A_1 . Under the pertur-



Fig. 5. Differential reflectance, $\delta R/R$, vs. electrode potential curves: modulation amplitude 50 mV_{p-p} , f = 11 Hz; potential was scanned cyclically from -1.080 to +0.02 V at 3.6 mV s^{-1} ; *p*-polarized light, angle of incidence, $\phi = 59^{\circ}$: (a) 380 nm; and (b) 680 nm. Inset: $\delta R/R$ vs. electrode potential plot showing the region between -0.82 and -0.20 V, forward and back scans, sweep rate 2.6 mV s^{-1} . Other conditions as in main graph.

bation applied the process A_2/C_2 appears as poorly reversible, that is, does not seem to follow the modulation. The transformation associated with these maxima gives rise to a strongly surface species, probably attended by deprotonation, with similar properties to a two-dimensional silver sulphide that can be optically detected at both 380 and 680 nm.

As the potential is made more positive a maximum can be observed corresponding to the formation of phase silver sulphide under diffusion control, identified as A_3 on the cv, followed by a peak revealing the presence of postwave A_4 , this process is detected at 380, but not at 680 nm; this fact points to the different optical properties of the underlying thin layer in comparison with that of the bulk silver sulphide deposit. The subsequent slanting profile, even after the potential reversal, arising from the growth of phase silver sulphide, its reduction being noticed at -0.500 V on the back scan. Peak C_4 does not show up in the optical profile. The tiny signal at -0.635 V points to the modulation of process C_2 , better resolved on the reverse sweep than on the forward scan because of an increase in surface roughness. A similar enhancement in magnitude is observed for the peak at -0.915 V, on the negative-going scan, arising from the change of electrode area. On the other hand, when similar measurements are carried out at 680 nm (Fig. 5b) in addition to having a much weaker signal, there are some differences to be noted, namely, the maximum corresponding to reaction A_4 is absent, as described earlier. On the negative-going scan, the most interesting feature is observed in the reduction region of silver sulphide, the trailing edge of the maximum is characterized by the presence of a sharp peak. This behaviour was found to be reproducible and clearly detected. The spectrum of phase silver sulphide, as grown under our experimental conditions, reveals a significant contribution from the excitation of surface plasmons (vide supra). In the potential region where this peak shows up, the silver surface should be partially covered by silver sulphide patches not yet reduced. Besides, the freshly reformed silver layer has got a rough and porous structure[4, 5]. Thus, the spike observed may come from the excitation of surface plasmons as a consequence of the experimental conditions developed in the process of silver sulphide reduction. That is, the coupling between light and metal may take place through the rough silver surface reformed during silver sulphide dissolution[19]. Another possibility is that the silver sulphide irregular layer could act as a coupler for the light in a way similar to that described in [20] for pyridine films.

Acknowledgements—This work was supported by grants from the Consejo Nacional de Investigaciones Científicas y Técnicas and the Comisión de Investigaciones Científicas de la Provincia de Buenos Aires.

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